



1763

In re application of: Jian J. Chen

Attorney Docket No.: LAM1P151 *HS*

Application No.: 09/676,269

Examiner: UNKNOWN

Filed: September 28, 2000

Group: UNKNOWN

Title: Chamber Configuration for Confining a
Plasma

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the
United States Postal Service as First Class Mail to: Commissioner for
Patents, Washington, DC 20231 on September 28, 2001.

Signed: *Sunshine Noriega*

Sunshine Noriega

**RESCISSON OF NONPUBLICATION REQUEST
UNDER 35 U.S.C. 122(b)(2)(B)(ii) AND
NOTIFICATION OF INTERNATIONAL FILING
UNDER 35 U.S.C. 122(b)(2)(B)(iii)**

Commissioner for Patents
Box Patent Application
Washington, DC 20231

Sir:

I hereby rescind any previously filed request that the above-identified application not be published under 35 U.S.C. 122(b). In addition, this communication is a notification that within the last forty-five days, at least one application directed to the invention disclosed in the above-identified application has been filed in another country, or under a multilateral international agreement, that requires publication of applications eighteen months after filing.

Date: 9-28-01

Mary
Mary R. Olynick
Registration No. 42,963

NOTE:

This request must be signed in compliance with 37 CFR 1.213(c) and submitted not later than 45 days after the filing of any such foreign or international application.

As a result of filing this request, the application will be scheduled for publication at eighteen months from the earliest claimed filing date for which a benefit is claimed.

RECEIVED
OCT 05 2001
TC 1700